Contents lists available at ScienceDirect



Journal of the Mechanics and Physics of Solids

journal homepage: www.elsevier.com/locate/jmps

Mechanics of nanocrack: Fracture, dislocation emission, and amorphization

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ARTICLE INFO

Article history: Received 23 September 2008 Received in revised form 15 December 2008 Accepted 16 January 2009

Keywords: Nanocrack Fracture Lattice trapping Brittle-to-ductile transition

1. Introduction

ABSTRACT

Understanding the nanoscale fracture mechanisms is critical for tailoring the mechanical properties of materials at small length scales. We perform an atomistic study to characterize the formation and extension of nano-sized cracks. By using atomistic reaction pathway calculations, we determine the energetics governing the brittle and ductile responses of an atomically sharp crack in silicon, involving the competing processes of cleavage bond breaking, dislocation emission, and amorphization by the formation of five- and seven-membered rings. We show that the nanoscale fracture process depends sensitively on the system size and loading method. Our results offer new perspectives on the brittle-to-ductile transition of fracture at the nanoscale.

Nanoscale fracture experiments and simulations demonstrate the potential to probe and exploit the ultimate strength of materials (Belytschko et al., 2002; Han et al., 2007; Khare et al., 2007; Lee et al., 2008; Peng et al., 2008; Pugno and Ruoff, 2004; Yu et al., 2000; Zhang et al., 2005). These studies also point to the need for an understanding of the mechanisms governing the formation and extension of nanometer-sized cracks in a broad range of fields and applications (Celarie et al., 2003; Gao et al., 2003; Guin and Wiederhorn, 2004; Mielke et al., 2007; Ritchie et al., 2004). Here we present an atomistic study of nanoscale fracture mechanisms under ultra-high stresses, being close to but below the ideal tensile strength, i.e., the athermal limit of instantaneous fracture. Such high stresses can easily arise in materials with nanometer-sized cracks. While the nanocrack response in this sub-critical load range controls the fracture behavior of small-volume materials, only few theoretical studies have emerged in recent years (e.g., Bernstein and Hess, 2003; Perez and Gumbsch, 2000a, b; Zhang et al., 2007). This is largely because from an atomistic-modeling standpoint, the fracture under a sub-critical load is hardly accessible by direct molecular dynamics (MD) simulations due to the time-scale constraint (Voter et al., 2002). To overcome the time-scale limitation of MD, we adopt the nudged elastic band (NEB) method (Jonsson et al., 1998) to model the sub-critical fracture in terms of the energetics of nanocrack formation and extension.

The quantification of atomic-level energetics clearly reveals an essential feature of fracture in crystals: the lattice discreteness causes the atomic-scale corrugation of the energy landscape, giving rise to the lattice-trapping effect (Thomson et al., 1971). Specifically, under an applied load, a crack can be locally "trapped" in a series of metastable states with different crack lengths and crack-tip atomic structures. The time-dependent kinetic crack extension then corresponds

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^{0022-5096/\$ -} see front matter \circledast 2009 Elsevier Ltd. All rights reserved. doi:10.1016/j.jmps.2009.01.006

to the transition of the system from one state to the other via thermal activation (Rice, 1978). This lattice-trapping effect is expected to play an increasingly important role in fracture with reduced system size, though its significance varies for different crystals, depending on the bonding characteristics such as the interaction range and shape of the interatomic force law (Curtin, 1990; Sinclair, 1975; Zhang et al., 2007). From the atomistic-modeling perspective, the existence of lattice-trapped states enables us to capture and examine in detail various brittle and ductile responses, including the competing processes of cleavage fracture, dislocation emission, and amorphization (Bernstein and Hess, 2003; Warner et al., 2007; Zhu et al., 2004, 2006).

In this paper, we examine the thermodynamic driving forces and activation barriers associated with growth of a crack, dislocation emission, and amorphization at a crack tip subjected to either stress or strain loading. We show that for a Stillinger–Weber (SW) potential of silicon (Stillinger and Weber, 1985), amorphization is most favored both thermodynamically and kinetically. Based on this result, amorphization is expected to be the dominant crack-tip response. This prediction is consistent with direct MD simulations (Bernstein and Hess, 2003; Buehler et al., 2007), but is valid for a much wider range of stresses, temperatures, and loading rates. We further investigate the energy landscape beyond the initial formation of dislocations and five/seven-membered rings. Our results exhibit energy barriers that govern the subsequent defect migration and nucleation. The competition of these defect processes dictates stress relaxation at a crack tip, and controls fundamentally the brittle-to-ductile transition of fracture.

2. Nanocrack formation and size effect

Consider a central crack in an otherwise perfect crystal of silicon under a uniform far-field load. We use the standard supercell setup with periodic boundary conditions (Parrinello and Rahman, 1981). The silicon atoms form a diamond-cubic crystalline network, characterized by localized and directional covalent bonds that generally enhance the lattice-trapping effect (Sinclair, 1975). Consider the silicon under a high stress of 10 GPa, about 1/4 of the ideal tensile strength in the $\langle 111 \rangle$ direction, 38 GPa, as predicted by the SW potential (Zhu et al., 2006). We determine the atomic geometry and energetics of formation and extension of a nano-sized crack. Here we focus on quasi-2D fracture and ignore the 3D mechanism of crack advancement by double-kink formation and migration along the crack front (Marder, 1998; Sinclair, 1975; Zhu et al., 2004).

Fig. 1(a) shows the system energy per unit cell along the crack front as a function of crack length under both the stresscontrolled (red) and strain-controlled (blue) loading conditions. In this calculation, the supercell is 18.3 nm wide, 20.1 nm high, and 3.8 nm thick, with a total of 1680 atoms. In Fig. 1(a), circles represent the local energy minima at different crack lengths, i.e., different numbers of broken bonds. These metastable states arise because of the lattice-trapping effect. They are numerically obtained by using the constrained energy minimization method, as detailed in Appendix A2. The attainment of these states enables us to quantitatively evaluate the applicability of the Griffith theory to nanoscale fracture. According to this theory (Lawn, 1993), fracture occurs at a critical crack length when the system energy maximizes. From the envelop curve connecting circles (dashed line), we determine the Griffith crack lengths for stress-controlled and straincontrolled fractures; both are close to $2a_c \approx 2.8$ nm. On the other hand, the critical crack length can be predicted based on the Griffith formula. Namely, the critical energy release rate G_c and the stress intensity factor K_c satisfy the condition of $G_c = K_c^2/E' = (\sigma \sqrt{\pi a_c})^2/E' = 2\gamma_s$; using the surface energy ($\gamma_s = 1.45 \text{ J/m}^2$) and effective Young's modulus in the $\langle 111 \rangle$ direction (E' = 148.6 GPa) given by the SW potential (Zhu et al., 2006), one predicts $2a_c = 2.74 \text{ nm}$, as indicated by the vertical line in Fig. 1(a). The agreement between the two methods of predicting the critical crack length, with a difference less than one atomic spacing of 0.33 nm, suggests that the Griffith formula is applicable to nanoscale fracture. Note that the above estimate of the stress intensity factor, $K = \sigma \sqrt{\pi a}$, ignores the finite-size effect of the system. We have validated this approximation, as shown later in the study of the image-crack effect.

In Fig. 1 (a), each curve connecting two adjacent circles measures the energy variation along the minimum energy path (MEP) (Jonsson et al., 1998) for breaking or healing one crack-tip bond, i.e., crack extension or receding by one bond distance. These MEP curves are calculated from the nudged elastic band method, as detailed in Appendix A. Each MEP involves a forward and a backward transition. We extract the energy barriers along the thermodynamically favorable directions of transition. So the activation energies shown in Fig. 1(b) are the barriers of crack extension when $a > a_c$, and the barriers of crack healing when $a < a_c$.

Fig. 1 also reveals the size effect on nanoscale fracture. In Fig. 1(c), we compare the energies governing the stresscontrolled fracture in two supercells, $18.3 \text{ nm} \times 20.1 \text{ nm}$ (red curve) and $9.1 \text{ nm} \times 10 \text{ nm}$ (brown curve). Fig. 1(d) shows the energetics of strain-controlled fracture in two supercells, $18.3 \text{ nm} \times 20.1 \text{ nm}$ (blue curve) versus $9.1 \text{ nm} \times 10 \text{ nm}$ (green curve). Comparing Figs. 1(c) and (d), one sees a significant size effect on strain-controlled fracture, whereas stresscontrolled fracture is not sensitive to the system size.

To further reveal the effects of loading method and system size, we regroup the curves in Figs. 1(c) and (d), and show in Fig. 1(e) the energies of stress-controlled (brown) and strain-controlled (green) fracture in the size-reduced system (9.1 nm × 10 nm). In contrast to Fig. 1(a), the two loading methods lead to considerably different energy curves. This difference arises because the strain-controlled fracture is more sensitive to the system size. Fig. 1(f) shows the energy barriers of crack extension, extracted from Fig. 1(e). Particularly, when $a > a_c$, the energy barrier for strain-controlled fracture (green circles) first decreases and then increases as the crack further extends. This trend differs qualitatively from



Fig. 1. Nanoscale fracture in silicon under the tensile stress of 10 GPa. (a) Energetics of nanocrack formation under the stress-controlled (red) and strain-controlled (blue) loading conditions. (b) Energy barriers of crack extension and healing extracted from (b). For (a) and (b), the supercell size is 18.3 nm × 20.1 nm × 3.8 nm, and the crack length is 2a = dn, where *d* denotes the distance between neighboring bonds (about 3.3 Å) in the direction of crack extension, *n* is the number of broken bonds, and an empirical cut-off radius of 2.58 Å is used to determine whether a bond perpendicular to the crack plane is broken. (c) Size effect on stress-controlled fracture, showing the energetics of crack in the supercells of 18.3 nm × 20.1 nm × 3.8 nm (red) and 9.1 nm × 10.1 nm × 3.8 nm (brown). (d) Size effect on strain-controlled fracture, showing the energetics of crack in the supercells of 18.3 nm × 20.1 nm × 3.8 nm (red) and 9.1 nm × 10.1 nm × 3.8 nm (green). (e and f) Same as (a and b) except the supercell is reduced by half in both width and height. (g) Relaxed atomic configuration with a nanocrack at the critical length of Griffith's fracture, $2a_c \approx 3$ nm; the supercell size is 9.1 nm × 10.1 nm × 3.8 nm and the corresponding energetics of fracture is shown in (e) and (f). For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.

the case when the system size is doubled, see Fig. 1(b) (blue circles). This change in energy barriers can be correlated to the thermodynamic driving force of crack extension, i.e., $G(a)-2\gamma_s$ (Rice, 1978), which corresponds to the negative of the slope of the envelope curve in Fig. 1(e). Specifically, during the strain-controlled fracture and when $a > a_c$, our calculations show that the system stress σ decreases when a increases. As the crack extends, the effect of σ on reducing $G = \sigma^2 \pi a/E'$ overrides that of crack length a on increasing G, causing a net decrease in G and hence an increase in the energy barrier. The implication of this result is that crack extension can be kinetically delayed for a long crack; namely, the kinetic rate of crack growth decreases with the increasing crack length. Our results demonstrate that such kinetic delay can be enhanced by reducing the system size.

The above size effect can be rationalized in terms of the interactions between the central crack and its images, which arise due to the finite size of the simulation cell and periodic boundary conditions. Fig. 2 shows the central supercell, with the characteristic size of 2*b*, and eight neighboring cells. When *b* is reduced, the central crack and its image-cracks become closer, causing stronger interactions leading to the observed size effect. To evaluate the extent of size effect, we have further studied larger supercells. For example, in a size-doubled system (37 nm × 40 nm), we find that for both the stress-controlled and strain-controlled fractures, the energy curves are close to those in Figs. 1(a) and (b) with differences less than 1%. This suggests that the size effect on nanoscale fracture should become insignificant when b/a > 10 (Zhang et al., 2007). In other words, the size effect on the formation of nanocrack becomes increasingly important as the samples size is reduced into the range of tens of nanometers. It should be emphasized that such a nanoscale size effect is sensitive to the loading (boundary) conditions, as shown in Fig. 1.

From the above image-crack considerations, one may estimate the influence of system size on the stress intensify factor, K, which is an effective measure of the thermodynamic driving force of crack extension. Consider a periodic array of cracks of length 2*a* and spacing 2*b* under a far-field stress of σ^{∞} . It can be shown the corresponding $K = \sigma^{\infty}\sqrt{\pi a}\sqrt{(2b/\pi a)}\tan(\pi a/2b)}$ (Rice, 1968). When b/a = 10, $K = 1.004\sigma^{\infty}\sqrt{\pi a}$. This supports the notation that the size effect on fracture should become insignificant when b/a > 10.

We next explain why the strain-controlled fracture has a stronger size effect than the stress-controlled fracture when b/a < 10. For a large system subjected to strain loading, the elastic energy release with the introduction of a crack of length 2a is $\pi\sigma^{\infty 2}a^2/E'$ per unit thickness of the body (Lawn, 1993). This energy relation is derived by assuming that σ^{∞} is constant when a crack is introduced, a condition that is approximately satisfied for strain-controlled fracture when the system size is much larger than the crack length. Our calculations show that the system stress becomes very sensitive to crack length when b/a < 10, so that the elastic energy release should deviate from $\pi\sigma^{\infty 2}a^2/E'$ in small samples, leading to a strong size effect, as shown in Fig. 1(d). On the other hand, in a large system under stress loading, the introduction of a crack of length 2a causes a release of the potential energy (the sum of stored elastic energy and the work of applied stress) by the same amount of $\pi\sigma^{\infty 2}a^2/E'$ as the strain-controlled fracture. In small systems, σ^{∞} remains constant regardless of crack length, so that the energy release is still about $\pi\sigma^{\infty 2}a^2/E'$. This leads to a much weaker size effect, as shown in Fig. 1(c). While the foregoing analysis of size effects is given based on the continuum theory of elasticity and does not directly involve the atomic-scale effect of lattice, it should be emphasized that the characterization of energy barriers requires the sampling of corrugated atomistic energy landscape, and the detailed atomistic study is therefore needed, as demonstrated in this work.

Finally, we note that the strain-controlled fracture in the present central-crack setting qualitatively differs in the nature of stability from another celebrated case of displacement-controlled fracture: Obreimoff's experiment of inserting a wedge to peel off a surface layer in mica (Lawn, 1993). As shown in Fig. 1, a central crack under a uniform far-field load features a



Fig. 2. Illustration of the size effect on fracture, which arises because the crack in the central supercell (same as Fig. 1(g)) interacts with image-cracks in other supercells.

concave energy-crack length profile for both the stress-controlled and strain-controlled loadings. Consequently, the crack system is unstable since both the extension and healing of a crack from $a = a_c$ lower the total energy of the system. In contrast, the energy-crack length profile that characterizes Obreimoff's experiment is convex, much like an invert of what is shown in Fig. 1(a), so that the crack system is stable. This difference in crack stability can be qualitatively understood as follows: for the central-crack setting, the loads are applied by either the far-field stress σ^{∞} or strain $\varepsilon^{\infty} = \sigma^{\infty}/E'$. As detailed earlier, the introduction of a crack of length 2a in a large system causes a release of elastic energy or potential energy by the same amount of $\pi\sigma^{\infty 2}a^2/E'$ for the stress-controlled or strain-controlled fractures. In the meantime, the surface energy is increased by $2a\gamma_s$. As a result, their energy-crack length profiles are both concave, and qualitatively similar even in small systems. On the other hand, the peel-off layer in Obreimoff's experiment can be modeled by one arm of a split strip. The arm can be treated as a beam of length l and height h cantilevered at the crack tip. Under an end load of imposed displacement δ , the stored elastic energy is about $E'h^3\delta^2/4l^3$ per unit thickness of the beam, which is different from the stored potential energy of $-4l^3P^2/E'h^3$ under an end load of imposed force P (Freund, 1990). As a result of the different roles of crack length l in the beam energy, the system energy versus crack length curve changes from the concave to convex shape as the applied load switches from imposed displacement to force, leading to the change of crack stability.

3. Competing mechanisms of fracture, dislocation emission, and amorphization

To investigate the atomic mechanisms governing the brittle-to-ductile transition, we have studied several competing unit processes at the crack tip. Consider, as an example, a crack under a strain-controlled load. Suppose the system is subjected to a nominal stress of $\sigma = 10$ GPa and the crack length is 2a = 2.8 nm, which satisfies the Griffith condition of fracture. Fig. 3(a) shows the relaxed structure near the crack tip. Taking this configuration as an initial state, we determine the minimum energy paths of brittle fracture by bond breaking, Fig. 3(b1), the ductile responses by amorphization,



Fig. 3. Competing crack-tip processes at the critical condition of Griffith's fracture. (a) The relaxed crack-tip structure before transition. (b1) Relaxed structures after crack-tip bond breaking, (b2) amorphization, (b3) and dislocation emission; atoms are colored by the coordination number: 4 (green) and 3 (blue). (c) Minimum energy paths and (d) activation energy barrier versus crack length ($a > a_c$). For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.

Fig. 3(b2), and dislocation emission, Fig. 3(b3). We obtain these local energy minima (Figs. 3(b1)-(b3)) by using the constrained energy minimization method, as detailed in Appendix A2. Since brittle fracture has been discussed in detail in Section 2, we below describe the latter two processes.

We next examine the atomic process of crack-tip amorphization. The minimum energy path calculation shows that the initiation of amorphization proceeds via the rotation of a single silicon bond, as marked by the green oval in Figs. 3(a) and (b2), respectively. This bond rotation results in a pair of five- and seven-membered rings (stars in Fig. 3(b2)), in contrast to the six- and eight-membered rings in a perfect diamond-cubic structure. Such single bond rotation mechanism initiates the crack-tip amorphization process, as has been observed in direct MD simulations (Buehler et al., 2007). This mechanism has an important consequence on the energetics of amorphization to compete against fracture and dislocation emission, as will be discussed later in this article. Parenthetically, the unit process of bond rotation has been previously hypothesized as a fundamental mechanism of amorphization in bulk silicon, and employed to create the continuous random network of amorphous silicon, the so-called WWW method (Wooten et al., 1985). It is also noteworthy that a similar bond rotation mechanism leads to the formation of a Stone–Wales (SW) defect in the hexagonal lattice of carbon nanotubes and graphene sheets (Dumitrica et al., 2006; Yakobson, 1998; Zhang and Zhu, 2007). The SW defect is a pair of planar rings with five- and seven-members, which is also known as a 5/7 dislocation dipole. The separation of the dipole by dislocation migration is a mechanism underlying the plastic deformation of carbon nanotubes and graphene sheets. However, the SW-like defect in silicon is non-planar; it leads to amorphization rather than dislocation nucleation.

For the diamond-cubic silicon, the crack-tip dislocation nucleation on the {111} plane involves two possibilities: dislocation glides on the widely spaced shuffle plane, which cuts through single covalent bonds along the $\langle 111 \rangle$ direction, or on the narrowly spaced glide plane, which cuts through the triplets of covalent bonds inclined equally to the {111} plane; Fig. 3(b3) shows the glide and shuffle plane by the solid and dashed line, respectively. As the relative importance of the shuffle and glide dislocations in plasticity has not been fully resolved (Bulatov et al., 2001; Sun et al., 1993), we study in this work the nucleation of a {111} $\langle 11\overline{2} \rangle$ glide partial as a representative unit process to compete against fracture and amorphization. By comparing Figs. 3(a) and (b3), one sees the bond shearing process (marked by the brown oval) on the {111} glide plane (the solid line) in the $\langle 11\overline{2} \rangle$ direction. Note that this partial nucleation process involves not only the bond shearing between atoms 4 and 5, but also the bond breaking between atoms 5 and 6; the consequent effect on the energetics of nucleation is discussed next.

Fig. 3(c) shows the minimum energy paths of the three competing processes. Here we take the energy of the relaxed structure in Fig. 3(a) as a reference of zero energy. It can be seen that the initiation of amorphization is most favored both thermodynamically (with the lowest energy of the final state) and kinetically (with the lowest activation energy barrier). By comparing the structure before transition, Fig. 3(a), with those after transition, Figs. 3(b1)–(b3), one can rationalize the thermodynamic preference to amorphization in terms of the number of silicon bonds, which is conserved after bond rotation (switching). In contrast, both fracture and dislocation emission involve bond breaking, as evidenced by the increased number of under-coordinated (blue) atoms. As a result, the latter two processes are subjected to a larger energy penalty, raising the energy level of the final states.

Fig. 3(d) shows the energy barriers of the three processes at various crack lengths. Generally, the brittle-to-ductile transition of fracture requires the crossover of barrier curves between the competing crack-tip processes. However, for this model of silicon based on the SW potential, it can be seen that amorphization is always the most kinetically favorable mode with the lowest activation energy barrier, until the load is increased to the athermal limit of spontaneous amorphization giving a vanishing energy barrier. According to transition state theory (Vineyard, 1957) and assuming that the three processes have approximately the same trial frequency (because each process similarly involves the transformation of a single bond), amorphization is expected to be the dominant crack-tip response at various stresses, temperatures, and loading rates, as observed in MD simulations using the same potential (Bernstein and Hess, 2003). Here, it should be pointed out that different interatomic potentials of silicon have been compared for predicting the mechanical properties (Balamane et al., 1992; Kang and Cai, 2007; Zhu et al., 2006). Results showed that whereas these empirical potentials facilitate the simulations in much larger systems with realistic microstructures compared to the *ab initio* method, they all have issues in characterizing the defective states of crystalline and amorphous structures of silicon. The improved fitting formalism and method are needed.

4. Evolving processes of amorphization and dislocation emission

We have further investigated the crack-tip amorphization beyond the initial formation of a pair of five- and sevenmembered rings. Competing pathways are identified for evolving the crack-tip amorphous structure. Starting from the incipient amorphous state shown in Fig. 3(b2), but at a slightly increased stress of 12 GPa, we find amorphization can proceed through the separation of existing five- and seven-membered rings by migration along the upper crack surface, Figs. $4(a_1) \rightarrow (a_2) \rightarrow (a_3)$. In addition, we have identified an alternative pathway of amorphization, Figs. $4(a_1) \rightarrow (a_2) \rightarrow (a_4)$. Fig. $4(a_4)$ shows that a new pair of five- and seven-membered rings (blue diamonds) forms shortly after the first pair (pink stars) is separated. In Fig. 4(b), we plot the minimum energy paths of these two competing pathways. Of particular interest is that compared to the transition from (a2) to (a3), going from (a2) to (a4) leads to a larger energy decrease, thus giving a stronger thermodynamic driving force. But the latter mechanism has a higher energy barrier, so that the kinetic rate could be lower if assuming the trial frequency is approximately the same for the two competing processes.



Fig. 4. Crack-tip amorphization beyond the first step of formation of a pair of five- and seven-membered rings. Two competing pathways are identified. $(a_1) \rightarrow (a_2) \rightarrow (a_3)$: separation of a pair of five- and seven-membered rings (pink stars). $(a_1) \rightarrow (a_2) \rightarrow (a_4)$: formation of a new pair of five- and seven-membered rings (blue diamonds). (b) Minimum energy paths of the two pathways. For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.



Fig. 5. Dislocation emission beyond the first step of forming a crack-tip glide partial: (a) zoom-out view of Fig. 3(b3); (b) a partial glides into the crystal along the inclined {111} slip plane; the dislocation cores are circled. (c) MEPs from state (a) to (b).

The foregoing two pathways of amorphization demonstrate a general feature of inelastic deformation in silicon: accommodating the applied load through the competing and complementary processes of *migration* of existing topological defects (e.g., the five- and seven-membered rings) and *nucleation* of the new ones. Such competition is expected to be important for most covalent solids such as silicon, where the intrinsic lattice resistance is high, causing the sluggish motion of existing defects whose back stresses promote the nucleation of new defects to sustain large deformation (Argon, 2001). The sluggish motion of defects can be further demonstrated by finding the non-negligible secondary barriers on the energy landscape. As an example, Fig. 5 shows the minimum energy paths of nucleation and migration of a glide partial from the crack tip. It is seen that the saddle point of the second step has the highest energy, which should act as the rate-limiting step of crack-tip dislocation nucleation.

Altogether, the present study shows that detailed analyses are further needed to fully understand the competing role of nucleation and migration of defects in silicon in terms of the thermodynamic driving force and kinetic barrier. These competing processes dictate the crack-tip stress relaxation, thereby controlling the brittle-to-ductile transition. A quantitative characterization of these processes is also critical to the coarse-grained modeling of the time-dependent crack growth by e.g., the kinetic Monte Carlo or cohesive finite element method (Serebrinsky et al., 2004).

5. Concluding remarks

We have studied the sub-critical fracture at the nanometer scale. As shown in Fig. 1, the influence of boundary conditions is quantified in terms of both the thermodynamic driving forces (energy difference between adjacent local energy minima (circles)) and kinetic barriers (energy difference between saddle points and neighboring local energy

minima). We find the strain-controlled fracture depends sensitively on the system size, leading to an intriguing scenario of kinetically delayed fracture with reduced system size. Moreover, the lattice-trapping effect enables us to perform an atomistic analysis of the geometry and energetics of competing crack-tip processes, including cleavage bond breaking, dislocation emission, and amorphization. We demonstrate that amorphization by single bond rotation is the most favorable atomic process until the athermal limit, making the brittle-to-ductile transition less likely. Obviously, in view of the imprecision of force-field models, verification via first principles calculations is needed to ascertain the conclusion. However, our studies also reveal the complexity of the energy landscape that is associated with subsequent growth of amorphization. To lay the groundwork for first principles calculations, such molecular mechanics studies are insightful. Further, it should be noted that at elevated temperatures, all the three crack extension mechanisms may be active, leading to a complicated, coupled crack extension process. Nevertheless, the present study represents the first necessary step towards a mechanistic understanding of the brittle-to-ductile transition of fracture. The atomistic modeling along the lines presented here is now feasible for characterizing the brittle versus ductile responses in different material systems, as well as the time-dependent kinetic crack growth caused by, for example, the cyclic-loading (Muhlstein et al., 2002) or chemical attack of foreign molecules (Ogata et al., 2004; Zhu et al., 2005).

Acknowledgements

SH and TZ are supported by the NSF Grants CMMI-0758554 and CMMI-0758265. SZ acknowledges the support under the NSF Grants CMMI-0826841 and CMMI-0600642. TB acknowledges his support under Army Research Office under Grants W911NF-05-1-0049/P00002 and W911NF-08-1-0212.

Appendix A. Methods

We have employed the nudged elastic band (NEB) method (Jonsson et al., 1998) to determine the energetics of nanoscale fracture under both the strain- and stress-controlled loading conditions. The modeling of strain-controlled fracture involves a straightforward application of the standard NEB method. However, care must be taken in the study of stress-controlled fracture. Importantly, under large deformation, the work done by the applied stress could be path-dependent, to be shown in Section A3.3. Below we first briefly review the notations used in our supercell-based modeling, and then introduce the strain-controlled NEB method for fracture modeling. Finally, we derive the formulation for the stress-controlled NEB method.

A1. Supercell-based modeling

As we consider the central-crack setting under a uniform far-field load, it is natural to use the standard supercell setup with periodic boundary condition (Parrinello and Rahman, 1981). The supercell can have arbitrary shape and size being completely described by three vectors, a_i , b_i , and c_i , that span the edges of the cell. To represent the general deformation, the vectors can have any lengths and mutual orientations. One may arrange the three vectors as $[a_i, b_i, c_i]$ to form a 3 × 3 matrix h_{ij} . The position of an atom within the cell can be written in term of h_{ij} and the reduced coordinate s_i ($0 \le s_i \le 1$)

$$x_i = h_{ij}s_j \tag{A.1}$$

The volume of the supercell is $det(h_{ij}) = n\Omega$, where *n* is the number of atoms in the cell and Ω is the volume per atom. At equilibrium, the effective far-field load is equal to the internal Virial stress, as given later.

As commonly done in continuum mechanics, one may take h_{0ij} as a reference state, which does not need to be stress free. For a homogenous deformation of the supercell from h_{0ij} to h_{ij} , the deformation gradient F_{ij} can be calculated by

$$F_{ij} = h_{ik} h_{0kj}^{-1}$$
(A.2)

and the volume per atom in the two supercells are related by $\Omega = J\Omega_0$, where $J = \det(F_{ij})$.

A2. Strain-controlled nudged elastic band method

The modeling of strain-controlled fracture involves a direct application of the standard NEB method by adjusting the system size to the desired load level. The NEB calculation requires an input of both the initial and final states, corresponding to different local energy minima on the energy landscape. Suppose one takes as an initial state a relaxed structure with a certain crack length. This structure can be obtained in two steps: first set the atomic positions approximately according to the analytic displacement field of a crack in a linear elastic body, and then relax the system by using the conjugate gradient (CG) energy minimization method with the Broyden–Fletcher–Goldfarb–Shanno (BFGS) optimization algorithm. To study the competing processes of fracture, amorphization and dislocation emission, multiple end-states need to be identified. This can be achieved by a procedure of constrained energy minimization. Specifically, it is important to note that because of the short-ranged, directional bonding between silicon atoms, these competing processes

generally involve the localized transformation of one atomic bond. As such, one can focus on the highly stressed atomic bonds near the crack tip, as indicated by ovals in Fig. 3(a). We have studied various transformation modes, involving bond breaking, bond rotation, and bond shearing. In the paper, we present three representative modes with relatively low energy barriers, leading to cleavage fracture, amorphization, and dislocation emission. To obtain the relaxed end-state for each bond transformation mode by using the CG energy minimization, one needs to put the initial state within the basin of the end-state. This can be achieved by the energy minimization with local constraints. Consider bond breaking as an example. One can first increase the separation of the targeted bond, d, by about one half of an atomic spacing, and then relax the system using the CG minimization while fixing d. After relaxation, one needs to remove the constraint on d, and relax the system again to obtain the desired end-state. One exception is of particular note: below a certain length, the crack spontaneously closes upon relaxation, indicating that the metastable state of cracking vanishes on the energy landscape. This arises because the small crack opening is below the interaction range of silicon atoms, causing self-healing with vanishing energy barriers.

Incidentally, the above procedure of constrained energy minimization has also been applied to obtain the end-states in the NEB calculations of dislocation loop emission in metals such as Cu (Zhu et al., 2007, 2008). Because of the delocalized nature of metallic bonds, the constraints need to be imposed locally on a group of atoms across the slip plane. Finally, we note that to identify unknown end-states in a more predictive way, one can use, for example, the dimer method (Henkelman and Jonsson, 1999) or metadynamics (Laio and Parrinello, 2002).

After the initial and final states are identified, a discrete elastic band consisting of a finite number of replicas (or images) of the system is constructed by linear interpolation to connect the two end-states. Then a spring interaction between adjacent replicas is added to ensure continuity of the path, thus mimicking an elastic band. An optimization of the band, involving the minimization of the forces acting on the replicas, brings the band to the minimum energy path. The MEP is defined as a continuous path in a 3*N*-dimensional configuration space (*N* is the number of free atoms), with the property that at any point along the path the atomic forces are zero in the 3N-1 dimensional hyper-plane perpendicular to the path. The energy maximum along the MEP is the saddle-point energy, which gives the activation energy barrier. The calculation is considered to be converged when the potential force on each replica vertical to the path is less than 0.002 eV/A. We define the reaction coordinate as the normalized hyperspace arc length along the MEP. Empirically, the silicon bond length undergoing rupture can be taken as an approximate reaction coordinate.

A3. Stress-controlled nudged elastic band method

The stress-controlled NEB method involves a search of MEP in the space of $\{h_{ij}, s_j\}$. To remove the rigid body rotation, one only needs to consider the components in the upper triangle of the $[h_{ij}]$ matrix. As a result, there is a total of 3N+6 degrees of freedom. Compared to the strain-controlled NEB, one needs to supplement the forces that are work-conjugate to h_{ij} and s_j , respectively, as well as the stress work. Parenthetically, the stress-controlled NEB method developed by Caspersen and Carter (2005) only deals with applied hydrostatic pressure. Our development is general and applicable for any prescribed stress component, with an appropriate treatment of stress work.

A3.1. Forces work-conjugate to h_{ii}

Consider a small and homogenous deformation of the supercell by δh_{ij} . The position of an atom at x_i will change by

$$\delta x_i = \delta h_{in} s_n = \delta h_{in} h_{nm}^{-1} x_m \tag{A.3}$$

and its gradient is

$$\delta x_{ij} = \delta h_{in} h_{nm}^{-1} x_{mj} = \delta h_{in} h_{nj}^{-1} \tag{A.4}$$

Assuming all the atoms are uniformly displaced, the incremental work associated with this small change δh_{ij} is

$$\delta W = V \sigma_{ij} \delta x_{i,j} = V \sigma_{ij} h_{nj}^{-1} \delta h_{in} = V_0 S_{ij} h_{0nj}^{-1} \delta h_{in}$$
(A.5)

where the Cauchy stress σ_{ij} is related to the first Piola–Kirchhoff (PK1) stress S_{ij} by

$$\sigma_{ij} = S_{im} F_{jm} / J = S_{im} h_{ik} h_{okm}^{-1} / J \tag{A.6}$$

Suppose the supercell is subjected to an applied PK1 stress S_{ik}^a . Here, the use of the PK1 stress simplifies the stress-work calculation as shown in Section A3.3. Correspondingly, the forces work-conjugate to h_{ij} are

$$f_{ij}^{h} = V\pi_{ik}h_{jk}^{-1} - V_0 S_{ik}^{a}h_{0jk}^{-1}$$
(A.7)

where π_{ij} is the internal Virial (Cauchy) stress

$$\pi_{ij} = \frac{1}{\Omega} \sum \hat{f}_i r_j \tag{A.8}$$

where \hat{f}_i and r_j denote the interatomic force and distance, respectively, and the summation includes all the atoms in the supercell.

A3.2. Forces work-conjugate to s_i

Consider a small change of the internal coordinate s_i while holding the supercell fixed. The corresponding change in x_i is

$$\delta \mathbf{x}_i = \mathbf{h}_{in} \delta \mathbf{s}_n \tag{A.9}$$

The incremental work is

$$\delta W = f_i \delta x_i = f_i h_{ii} \delta s_i \tag{A.10}$$

so that the forces that are work-conjugate to s_i is

$$f_i^s = f_j h_{ji} \tag{A.11}$$

A3.3. The stress work

When a system is under the stress control, the total energy should include the work done by the applied stress when the system is deformed from the reference to current state. It should be emphasized that the stress work could be path-dependent. To illustrate this dependence, let us consider a simple example of uniaxial tension. Given an arbitrarily chosen reference state, the length of the bar is L_0 and the cross-section area is A_0 . The work due to an applied force P in stretching the bar from L_0 to L_1 is

$$W = \int_{L_0}^{L_1} P dL \tag{A.12}$$

If the first Piola–Kirchhoff stress S_{ij} is fixed in the course of elongation, the stress work is

$$W = \int_{L_0}^{L_1} S_{11} A_0 dL = S_{11} A_0 (L_1 - L_0) = P(L_1 - L_0)$$
(A.13)

Here we assume that the bar is aligned in the x_1 direction. In contrast, if the Cauchy stress σ_{ij} is fixed during elongation, the stress work is

$$W = \int_{L_0}^{L_1} \sigma_{11} A dL$$
 (A.14)

One should notice that the area of the cross-section A generally changes with elongation, so that the stress work depends on the specific relation between A and the length of the bar L. In other words, the stress work under the fixed Cauchy stress is path-dependent because the relation between A and L is a priori unknown, so that the numerical integration of Eq. (A.14) is necessary. To appreciate this path-dependence, let us consider two examples. Assuming the bar has a constant volume, the corresponding stress work is

$$W = \sigma A_0 L_0 \ln(L_1/L_0) \tag{A.15}$$

As a second example, assuming the linear variation of both *A* and *L*, namely, $A = (A_1 - A_0)\lambda + A_0$ and $L = (L_1 - L_0)\lambda + L_0$, where $0 \le \lambda \le 1$, the stress work is

$$W = \sigma \frac{A_0 + A_1}{2} (L_1 - L_0) \tag{A.16}$$

which is clearly different from Eq. (A.15).

In principle, one may use any stress measure in the stress-controlled NEB method. In our calculations we assume the first Piola–Kirchhoff stress S_{ij} is fixed. The corresponding stress work does not require numerical integration; based on Eq. (A.5), it is given by

$$W = V_0 S_{ij} h_{0nj}^{-1} (h_{1in} - h_{0in})$$
(A.17)

Rigorously speaking, we study in this work the nanoscale fracture under the first Piola–Kirchhoff stress. While this stress is not very different numerically from the Cauchy stress, making the distinction between the two stress measures is critical to ensuring the correct stress-work calculation, numerical stability, and self-consistency of results.

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